

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

re application of:

Group Art Unit:

1725

Bo Gu, et al.

Examiner:

Serial No.:

10/787,517

Filed:

February 26, 2004

For:

LASER SYSTEM AND METHOD FOR MATERIAL

PROCESSING WITH ULTRA FAST LASERS

Attorney Docket No.: GSIL 0191 PUSP

INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. § 1.97(b)

Mail Stop Amendment Commissioner for Patents U.S. Patent & Trademark Office P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and §§ 1.97-1.98, the references listed and identified on the attached Forms PTO/SB08A and/or SB08B are being submitted herewith for consideration by the Examiner. This Statement is being filed in accordance with 37 C.F.R. § 1.97(b).

While this Statement is being filed in compliance with the duty of disclosure, citation of the listed references is not to be construed as an admission that any of the references are "material" as defined under 37 C.F.R. § 1.56(b).

CERTIFICATE OF MAILING UNDER 37 C.F.R. § 1.8

I hereby certify that this paper, including all enclosures referred to herein, is being deposited with the United States Postal Service as first-class mail, postage pre-paid, in an envelope addressed to: Mail Stop friendment, Commissioner for Patents, U.S. Patent & Trademark Office, P.O. Box 1450, Alexandria, VA 22313150 on:

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David R. Syrowik

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No copies of the listed U.S. patent references or the listed U.S. patent application publication references have been included herewith pursuant to 37 C.F.R. § 1.98(a)(2). Consideration and entry into the record of the listed references is respectfully requested.

Respectfully submitted,

Bo Gu, et al.

David R. Syrowik

Reg. No. 27,956

Attorney/Agent for Applicant

Date: December 14, 2004

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PTO/SB/08A (10-96) [MODIFIED]
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Substitute for Form 1449A/PTO

Application 1 **INFORMATION DISCLOSURE** February 26, 2004 **Filing Date** STATEMENT BY APPLICANT First Named Inventor Bo Gu, et al. **Group Art Unit** 1725 (use as many sheets as necessary) **Examiner Name** 3 Attorney Docket Number GSIL 0191 PUSP Sheet of

			U.S. PATENT DO	CUMENTS	
Examiner Initials	Cite No.¹	U.S. PATENT DOCUMENT Kind Code ² Number (<i>if known</i>)		Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
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Substitute for	r Form 1449B/PTO			Complete if Known				
				Application Number	10/787,517			
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				Group Art Unit	1725			
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^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹Unique citation designation number. ²Applicant is to place a check mark here if English language Translation is attached.

Outpath to 1	Farm 1440B/BTO			Complete if Known			
	Form 1449B/PTO			Application Number	10/787,517		
	MATION E			Filing Date	February 26, 2004		
STATE	EMENT BY	AP	PLICANT	First Named Inventor	Bo Gu, et al.		
				Group Art Unit	1725		
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